

Applicant(s): Haoren Zhuang

A METHOD FOR PRODUCING A HARD MASK IN A
CAPACITOR DEVICE AND A HARD MASK FOR USE IN A
CAPACITOR DEVICE

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Fig. 1a
(prior art)

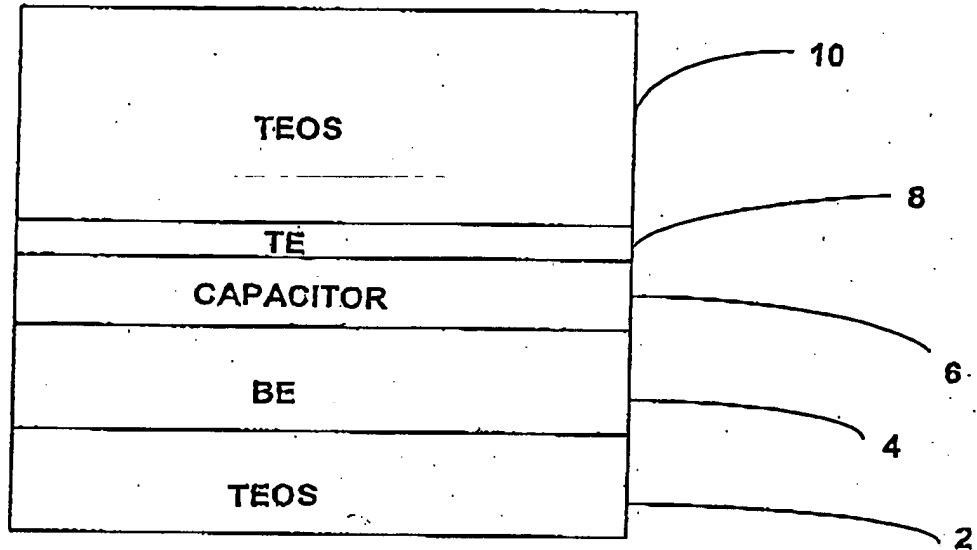
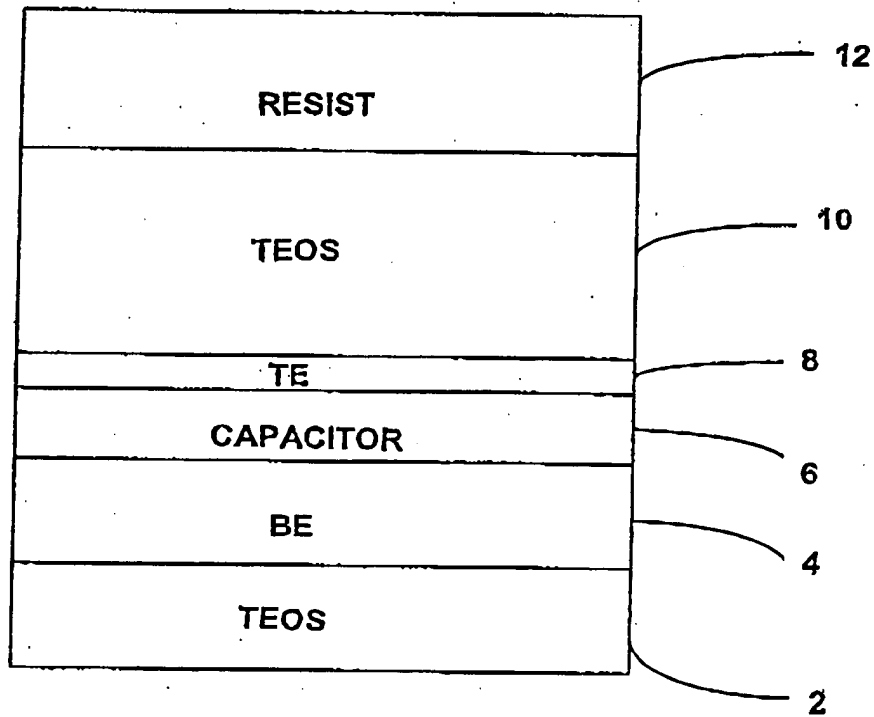


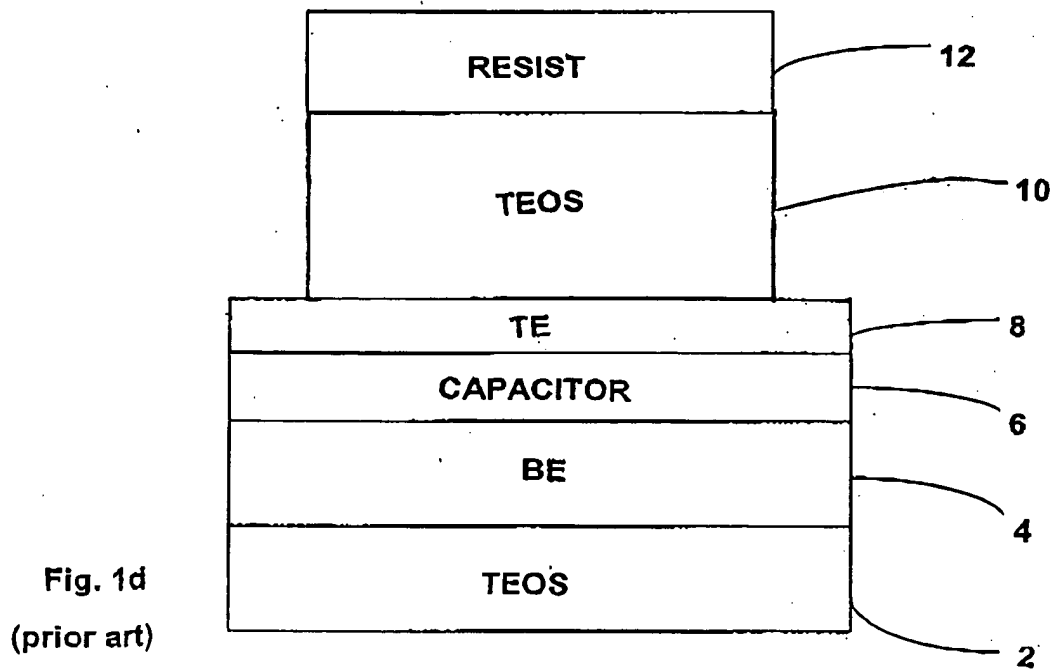
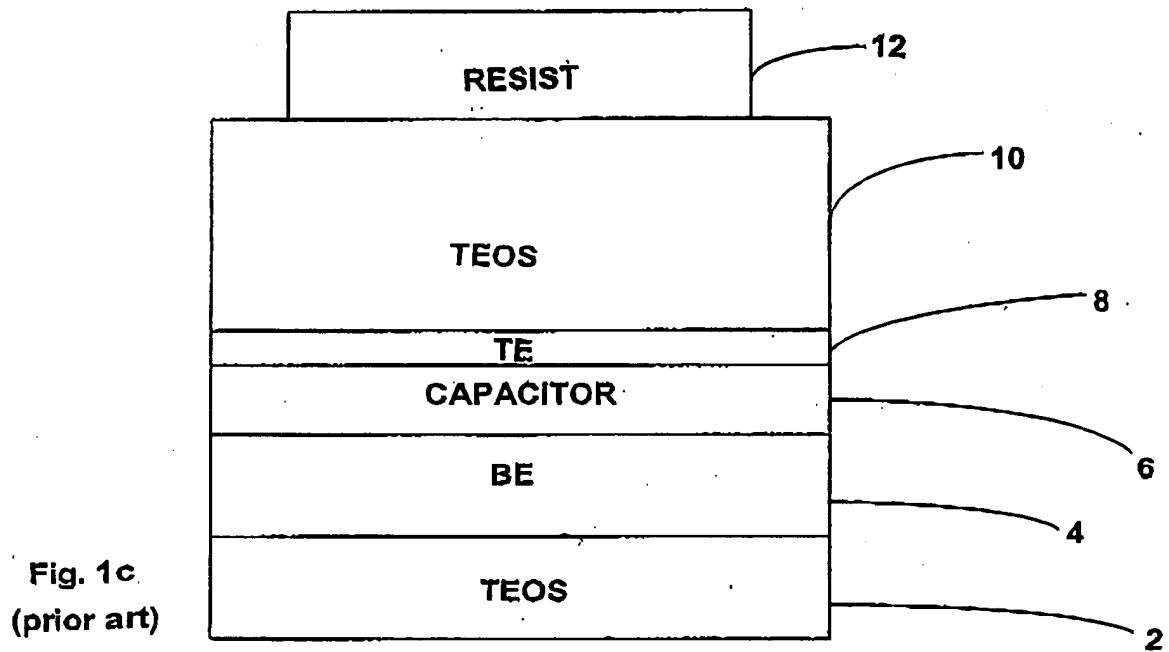
Fig. 1b
(prior art)



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Fig. 1e
(prior art)

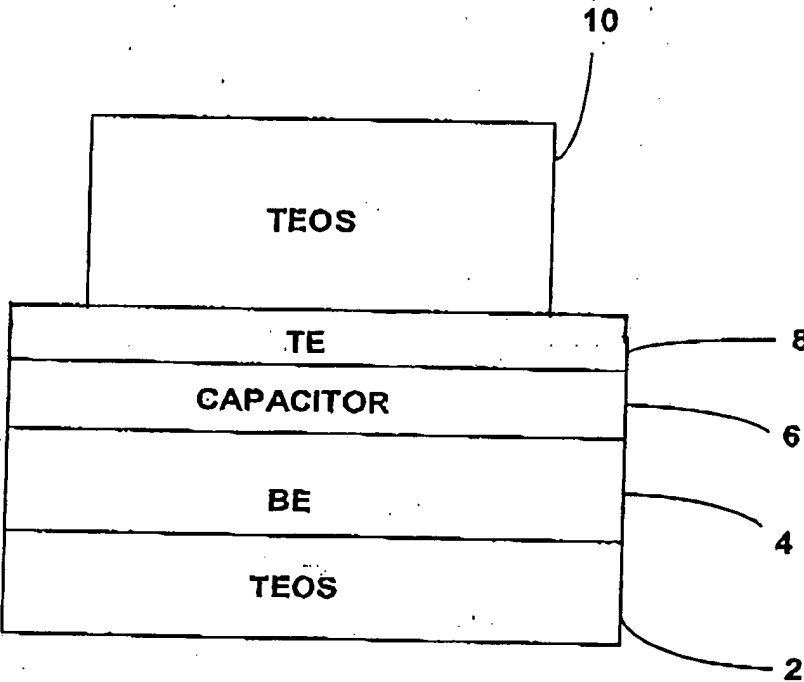
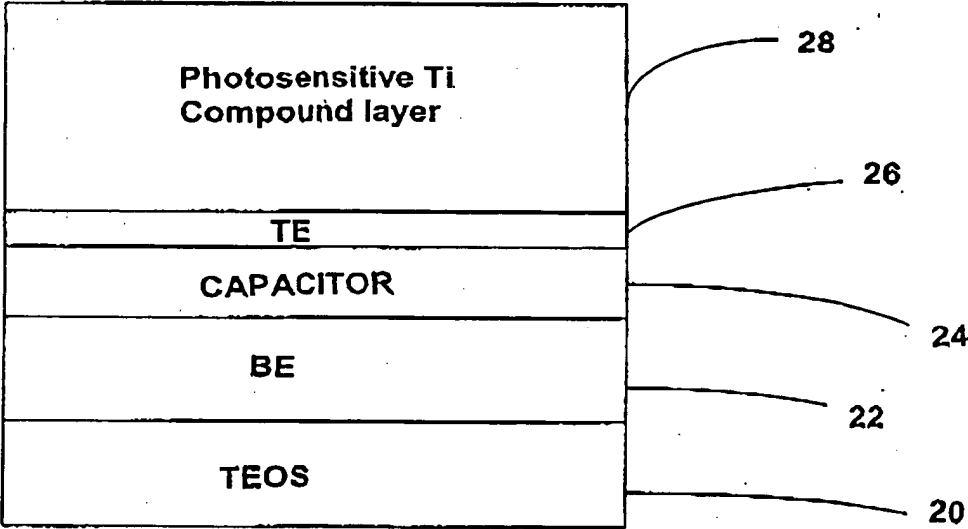


Fig. 2a



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Fig. 2b

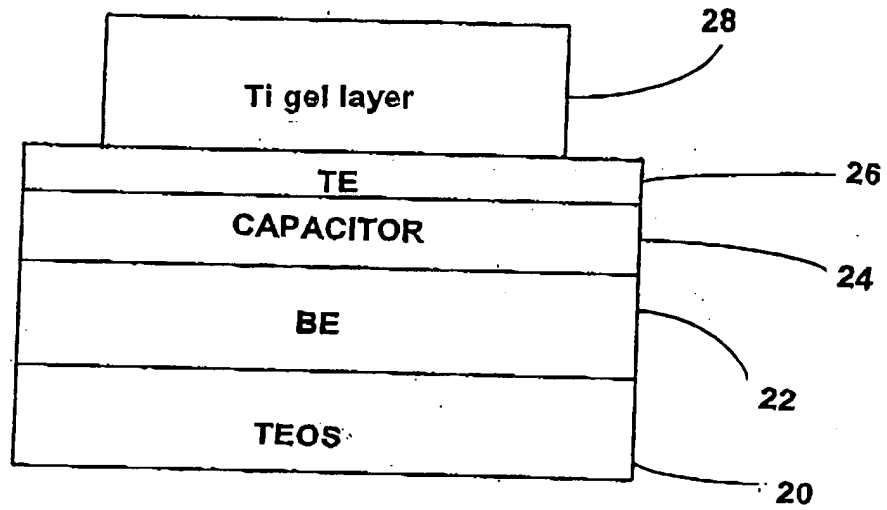


Fig. 2c

